IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

USA Patent Application

Jun Akedo

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ULTRA FINE PARTICLE FILM FORMING METHOD AND APPARATUS

Primary Examiner: M. Rachuba

Group art unit: 3723

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SIR:

AMENDMENT

In response to the Office Action dated August 21, 2003, please amend this application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.